

Attorney Docket No. 3180.0329

## NT 129

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
HARUKO AKUTSU ET AL.	) Group Art Unit: 2877
Application No.: 10/635,539	) Examiner: H. Pham
Filed: August 7, 2003	) Confirmation No.: 9696
For: APPARATUS AND METHOD FOR EVALUATING SEMICONDUCTOR MATERIAL	) ) )
Commissioner for Batenta	

P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(c)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(c), applicants bring to the attention of the Examiner the documents on the attached listing. This Information Disclosure Statement is being filed after the events recited in Section 1.97(b) but, to the undersigned's knowledge, before the mailing date of either a Final action, Quayle action, or a Notice of Allowance. Under the provisions of 37 C.F.R. § 1.97(c), this Information Disclosure Statement includes a certification as specified by Section 1.97(e).

Each document listed in this Information Disclosure Statement was first cited in a Notice of Grounds for Rejection issued by the Japanese Patent Office, mailed April 18, 2006, in a counterpart Japanese application, and this Information Disclosure Statement is being filed within thirty days of the mailing date of that communication. In accordance with 37 C.F.R. § 1.704(d), no negative patent term adjustment consequences will apply to this Information Disclosure Statement.

Copies of the listed foreign and non-patent literature documents are attached.

Applicants respectfully request that the Examiner consider the listed documents and indicate that they were considered by making appropriate notations on the attached form.

In lieu of a statement of relevance or translation of the non-English documents, an English language translation of the Notice of Grounds for Rejection issued by the Japanese Patent Office in the counterpart Japanese application citing these documents and setting forth the relevance thereof is enclosed. In addition, English-language Abstracts of the Japanese published applications are provided.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claims in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

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IDS Form PTO/S	IDS Form PTO/SB/08: Substitute for form 1449A/PTO			Complete if Known	
		(	MAY 1 8 2006	Application Number	10/635,539
INF(	ORMATION D	DISCLO SAL	RE	Filing Date	August 7, 2003
STA	INFORMATION DISCLOSURE STATEMENT BY APPLICANT		First Named Inventor	Haruko Akutsu	
317	AILMILMI DI	AFFLIOA	RADEMA	Art Unit	2877
	(Use as many sheets as necessary)			Examiner Name	H. Pham
Sheet	1	of	1	Attorney Docket Number	3180.0329

	U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite	Document Number	Issue or	Name of Patentee or	Pages, Columns, Lines, Where	
	No.¹	Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear	
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Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

	FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> ( <i>if known</i> )	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>	
		JP 6-318560	11/15/94	NEC Corp.		Abstract	
		JP 63-155628	6/28/88	Matsushita Electronics Corp.		Abstract	

	NON PATENT LITERATURE DOCUMENTS					
Examiner Initials						
		Notice of Grounds for Rejection issued by the Japanese Patent Office mailed April 18, 2006, for Japanese Patent Application No. 2003-100442, and English-language translation thereof				

Examiner	Date	
Signature	Consider	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.